



PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Young Hee MUN, et al.

Serial No.: 10/699,438

Filed: October 31, 2003

Title: SILICON WAFER AND
METHOD OF FABRICATING
THE SAME

Group Art Unit: 2822

Examiner: GUERRERO, Maria F.

Attorney Docket No.: 29936/39510

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November 6, 2006
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AMENDMENT "C"

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the official action dated May 5, 2006, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.